



Handwritten notes: #8/a, 8/5/02, and a signature.

Docket No.: 50090-338

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Hiroyuki AMISHIRO, et al.
Application No.: 09/960,495
Filed: September 24, 2001
For: SEMICONDUCTOR DEVICE WITH RESISTOR ELEMENTS FORMED ON INSULATING FILM (AS AMENDED)

Group Art Unit: 2813
Examiner: T.J. Sutton

AMENDMENT

Box Non-Fee Amendment
The Commissioner for Patents and Trademarks
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated April 5, 2002. Please amend the above-identified application as follows:

IN THE TITLE:

Please replace "SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING SAME" with --SEMICONDUCTOR DEVICE WITH RESISTOR ELEMENTS FORMED ON INSULATING FILM--.

07/09/2002 ANABI1 00000047 500417 09960495
01 FC:102 84.00 CH

08/06/2002 ASSTH 00000000 500417 09960495
01 FC:103 18.00 CH